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JPR

00862.022434.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
Shinichi SHIMA	:	Examiner: H. Nguyen
)	
Application No.: 09/986,958	:	Group Art Unit: 2851
)	
Filed: November 13, 2001	:	
)	
For: EXPOSURE APPARATUS, METHOD OF	:	April 24, 2002
MANUFACTURING SEMICONDUCTOR	:	
DEVICES, SEMICONDUCTOR MANUFAC-)	
TURING PLANT, METHOD OF MAINTAIN-	:	
ING EXPOSURE APPARATUS, AND POSITION)	
DETECTOR	:	

Commissioner for Patents
Washington, D.C. 20231

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

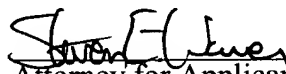
Further to the Information Disclosure Statement filed on January 17, 2002, in compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed PTO-1449 form. A copy of the listed document is also enclosed.

Applicant requests that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

We also enclose a check for the required fee of \$180.00 to cover the Information Disclosure Statement under 37 C.F.R. 1.97(c)(2). The Commissioner is authorized to charge Deposit Account No. 06-1205 should any other fees be deemed necessary in connection with this paper.

Applicant's undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicant
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